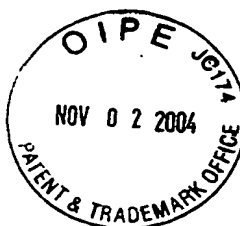


Docket Number: 081468-0309173
Client Reference: P-1583.010-US



JPW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

DE SMIT et al.

Group Art Unit: 2872

Application No.: 10/820,227

Examiner: TBA

Filed: April 8, 2004

Confirmation No.: 6925

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the following U.S. patent application(s):

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
	DE SMIT et al. (081468-0309978)	10/860,662	06/04/2004	<input checked="" type="checkbox"/> Specification <input checked="" type="checkbox"/> Drawings <input checked="" type="checkbox"/> Other: stamped receipt card

*The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.

It is respectfully requested that this application and the art cited therein during examination be expressly considered during the prosecution of this application and be made of record in this application. The identification of the above U.S. patent application is not to be construed as a waiver of secrecy as to that application now or upon issuance of the present application as a patent.

PLEASE DO NOT PRINT the above information on the patent which results from this application.

Consideration of the listed application is earnestly solicited since unpublished patent applications are contemplated as IDS material; see the exception in Rule 98(a)(2)(iii) and note the penultimate sentence of MPEP 609.

Further, in keeping with MPEP 609, subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE RETURN A COPY OF THIS LETTER** with the Examiner's initials adjacent the above listing so that applicant will know that the listed application has been considered as required by PTO policy.

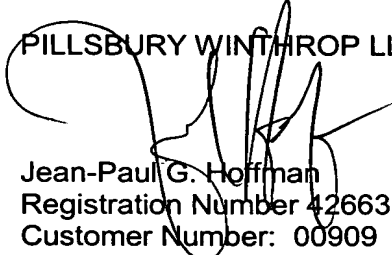
□ □

Secondly, please consider each enclosed document which is listed on the attached Form PTO-1449 and return a copy of that form with the Examiner's initials adjacent each citation. It is respectfully requested that these documents listed on the Form PTO-1449 be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

PILLSBURY WINTHROP LLP



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FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office



**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: November 2, 2004

Page 1 of 1

Atty.
Dkt. No.

M#

Client Ref.

309173

P-1583.010-US

Applicant: DE SMIT et al.

Appln. No. 10/820,227

Filing Date: April 8, 2004

Examiner: Unknown

Group Art Unit: 2872

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR 4,390,273	06/1983	LOEBACH et al.			
	BR 2004/0109237 A1	06/2004	EPPLÉ et al.			
	CR 6,236,634 B1	05/2001	LEE et al.			
	DR 2002/0020821 A1	02/2002	VAN SANTEN et al.			
	ER 2004/0119954	06/2004	KAWASHIMA et al.			
	FR 2004/0125351	07/2004	KRAUTSCHIK et al.			
	GR					

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclosed	No
	HR	WO 99/49504	09/1999	PCT	FUKAMI et al.	X		X	
	IR	JP 11-176727	07/1999	JAPAN	SHIRAISHI	X			
	JR	JP 2000-058436	02/2000	JAPAN	FUJISHIMA et al.	X			
	KR	WO 2004/053950 A1	06/2004	PCT	OWA	X			
	LR	WO 2004/053951 A1	06/2004	PCT	MAGOME et al.	X			
	MR	WO 2004/053952 A1	06/2004	PCT	MAGOME et al.	X			
	NR	WO 2004/053953 A1	06/2004	PCT	NEI et al.	X			
	OR	WO 2004/053954 A1	06/2004	PCT	NEI et al.	X			
	PR	WO 2004/053955 A1	06/2004	PCT	HIRUKAWA et al.	X			
	QR	WO 2004/053956 A1	06/2004	PCT	NAGASAKA et al.	X			
	RR	WO 2004/053957 A1	06/2004	PCT	HIDAKA et al.	X			
	SR	WO 2004/053958 A1	06/2004	PCT	MIZUTANI et al.	X			
	TR	WO 2004/053959 A1	06/2004	PCT	SHIRAI	X			
	UR	WO 2004/053956 A2	06/2004	PCT	GRAUPNER	X			
	VR	WO 2004/055803 A1	07/2004	PCT	VAN SANTEN	X		X	
	WR	WO 2004/057589 A1	07/2004	PCT	NEIJZEN et al.	X		X	
	XR	WO 2004/057590 A1	07/2004	PCT	VAN SANTEN et al.	X		X	
	YR	JP 2004-193252	07/2004	Japan	Not Available	X			
	ZR								
	AAR								
	BBR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

CCR				
DDR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.